



4

2823

Docket No.: 43890-485

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Hiroshi HAJI, et al.

Serial No.: 09/781,563

Filed: February 13, 2001

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

: Customer Number: 2027700
: Confirmation Number: 2296
: Group Art Unit: 2823
: Examiner: George R. Fourson III

RECEIVED
SEP 11 2003
TECHNOLOGY CENTER 2800

REQUEST FOR RECONSIDERATION

Mail Stop Non-Fee Response
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 8, 2003, having a three-month shortened statutory period for response set to expire on October 8, 2003, reconsideration of the above-identified application is respectfully requested in view of the following remarks.